

Electronic Patent Application Fee Transmittal

Application Number:	10631797			
Filing Date:	31-Jul-2003			
Title of Invention:	Substrate treatment apparatus and substrate treatment method			
First Named Inventor/Applicant Name:	Atsuro Eitoku			
Filer:	James Alan Finder/Norman Schiff			
Attorney Docket Number:	P/2699-28			
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Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
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Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
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Request for continued examination	1801	1	810	810
Total in USD (\$)				810